## Application/Control No. Applicant(s)/Patent Under Reexamination 10/698,486 KIM, DAE YOU Notice of References Cited Art Unit Examiner Page 1 of 1 David Y. Chung 2871 **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY US-6,411,359 06-2002 Kobayashi et al. Α 349/149 В US-6,583,844 06-2003 Mishima et al. 349/149 US-С US-D US-Е US-F US-G US-Н US-1 US-US-K US-L US-M **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν О Ρ Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U

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